



## PATENT APPLICATION

## RESPONSE UNDER 37 CFR §1.116 EXPEDITED PROCEDURE TECHNOLOGY CENTER ART UNIT 2851

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Naruhide KITADA et al.

Group Art Unit: 2851

Application No.:

10/697,307

Examiner:

M. KOVAL

Filed: October 31, 2003

Docket No.:

117563

For:

MONITOR SYSTEM FOR PROJECTION APPARATUS, PROJECTION

APPARATUS, MONITOR PROGRAM FOR PROJECTION APPARATUS, AND

MONITOR METHOD FOR PROJECTION APPARATUS

## **AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the February 17, 2006 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.